

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tadashi ISHIKAWA et al.
 Serial No. : 10/535,346
 Conf. No. : 7148
 Art Unit : 1793
 Examiner : Mark L. Shevin
 Filing Date : October 3, 2005
 For: : METHOD OF PRODUCTION OF STEEL PRODUCT WITH
 NANOCRYSTALLIZED SURFACE LAYER



Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on **April 5, 2010**

Signature: *Katy Chan-Parsons*

Katy Chan-Parsons

TRANSMITTAL LETTER

SIR:

Transmitted herewith an Amendment in response to Office Action mailed on January 4, 2010 for which the three month response period expires on **April 5, 2010** (April 4, 2010 is a Sunday).

☒ No additional fee is required.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT NUMBER EXTRA	RATE (\$)	FEE (\$)
TOTAL CLAIMS	12	minus	20	0	52.00	0.00
INDEPENDENT CLAIMS	1	minus	3	0	220.00	0.00
MULTIPLE DEPENDENT CLAIM ADDED				0	390.00	0.00
TOTAL DUE						0.00

☒ The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

Respectfully submitted,

Date: April 5, 2010

By: *Weining Wang*

Weining Wang (Reg. No. 47,164)

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